

FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.
TUEC.IP2005

SERIAL NO.
09/427,775

LIST OF ART CITED BY APPLICANT
(Use several sheets if necessary)

APPLICANTS
Kidd et al.

FILING DATE
October 26, 1999

GROUP
1762

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME OF INVENTOR	CLASS	SUBCLASS	FILING DATE (if appropriate)

FOREIGN PATENT DOCUMENTS

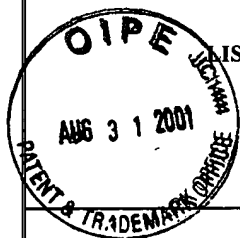
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO


OTHER ART

(Include name of author (in CAPITAL LETTERS), title of article, title of item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume issue number(s), publisher, city and/or country where published

EXAMINER INITIAL	
<i>nc merrish</i>	
<i>MLP</i>	BUNSHAH, R.F., Handbook of Deposition Technologies for Films and Coatings, 1994, Second Edition, Noyes Publications, Westwood, New Jersey U.S.A. (PLEASE NOTE: This reference was donated to Group Art Unit 1762 is available through Examiner Marianne Padgett for examination of this and other patent applications.)
<i>MLP</i>	
	DATE CONSIDERED: <i>4/3/02</i>

*EXAMINER: Please initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Please include copy of this form with next communication to applicants.





FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
TUEC.IP2005SERIAL NO.
09/427,775

LIST OF ART CITED BY APPLICANT

(Use several sheets if necessary)

MAR 27 2002

APPLICANTS
Kidd et al.FILING DATE
October 26, 1999GROUP
1762RECEIVED
APR 03 2002
TUEC 1762

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME OF INVENTOR	CLASS	SUBCLASS	FILING DATE (if appropriate)
<i>MPP</i>	3,756,847	Sept. 4, 1973	Donald Leibowitz et al.	117	93.3	Nov. 4, 1971
	3,961,103	June 1, 1976	Sol Aisenberg	427	39	Nov. 7, 1974
	4,126,521	Nov. 21, 1978	Coffin	204	15	Oct. 19, 1977
	4,310,614	Jan. 12, 1982	G. A. Neville Connell, et al.	430	271	Mar. 19, 1979
	5,085,499	Feb. 4, 1992	Jeffrey W. Griffin, et al.	356	311	Sep. 2, 1988
	5,798,496	Aug. 25, 1998	Paul S. Eckhoff	219	121.36	Apr. 8, 1996
	5,889,587	Mar. 30, 1999	Arthur P. D'Silva, et al.	356	316	Sep. 3, 1993
	6,090,157	Jul. 18, 2000	Traut et al.	8	149.3	Jan. 30, 1998
	6,153,270	Nov. 28, 2000	Russman et al.	427	522	
<i>MPP</i>	6,156,392	Dec. 5, 2000	Duffy et al.	427	475	Jul. 13, 1999

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
<i>MPP</i>	0-374-060-A1	June 20, 1990	EPO <i>DSummeria-Klen</i>	B23K	15/00		<input checked="" type="radio"/> No
	0-492-511-A2	July 1, 1992	EPO <i>Rose et al</i>	H01J	37/16	<i>in English</i>	<input checked="" type="radio"/> Yes
	0-653-252-A1	May 17, 1995	EPO <i>Butler et al</i>	B09C	1/06	<i>"</i>	<input checked="" type="radio"/> Yes
	DE-44-18-161-A1	Nov. 30, 1995	Germany <i>Rainer et al</i>				<input checked="" type="radio"/> No
	2118082	Oct. 26, 1972	Germany <i>Dietrich et al</i>				<input checked="" type="radio"/> No
<i>MPP</i>	WO-01/90436-A2	Nov. 29, 2001	WIPO <i>Kidd et al</i>	C23C	14/00	<i>in English</i>	<input checked="" type="radio"/> N/A
	WO-01/90437-A2	Nov. 29, 2001	WIPO <i>"</i>	C23C	14/00		<input checked="" type="radio"/> N/A

OTHER ART

(Include name of author (in CAPITAL LETTERS), title of article, title of item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume issue number(s), publisher, city and/or country where published

EXAMINER INITIAL	
<i>MPP</i>	Instructions for Low-Voltage Power Circuit Breakers, Types DS and DSL, pp. 1-82, I.B. 33-790-1F, Effective Oct., 1983, Westinghouse Electric Corporation, Switchgear Division, East Pittsburgh, PA. (<i>in the manual</i>)
<i>MPP</i>	ARONSON, A.J., CHEN, D. and CLASS, W.H., Preparation of Titanium Nitride by a Pulsed D.C. Magnetron Reactive Deposition Technique Using the Moving Mode of Deposition (Thin Solid Films), 1980, pp. 535-540, 72, Elsevier Sequoia S.A., Lousanne-Printed in the Netherlands. <i>act</i>
<i>MPP</i>	MATTOX, D.M., Fundamentals of Ion Plating (J. Vac. Sci. Technol.), Jan./Feb. 1973, pp. 47-52, Vol. 10, No. 1, Sandia Laboratories, Albuquerque, N.M.
<i>MPP</i>	GEIS, Charles G. and FAIRFUL, David Jr., Maintenance Program Manual, MPM-DS Breaker for Westinghouse Type DS Circuit Breakers and Associated Switchgear, Revision O Dated June 1, 1993, Westinghouse Electric Corporation, Nuclear Services Division, Pittsburgh, PA.

DATE CONSIDERED: *4/5/02*

*EXAMINER: Please initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Please include copy of this form with next communication to applicants.